

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	10	((("1024523") or ("5665607"))).PN.	US-PGPUB; USPAT; EPO; DERWENT	OR	OFF	2006/10/29 15:31
S2	14	216/56.ccls. and ((etch\$3 near stop\$3) same nitride)	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:49
S3	0	S2 and (releas\$3 near layer)	US-PGPUB; USPAT	OR	OFF	2006/10/29 15:32
S4	4	216/24.ccls. and (solar near cell)	US-PGPUB; USPAT	OR	OFF	2006/11/04 15:01
S5	196	"4" and polysilicon	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:49
S6	0	S4 and polysilicon	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:49
S7	89	(solar near cell) same (silicon same polysilicon)	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:51
S8	2	S7 same etch\$3	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:55
S9	38	S7 and @pd<"20021203"	US-PGPUB; USPAT	OR	OFF	2006/11/04 14:56
S10	0	((silicon near nitride or "Si.sub.3 N. sub.4") same silicn) same (solar near cell)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/04 15:04
S11	389	((silicon near nitride or "Si.sub.3 N. sub.4") same silicon) same (solar near cell)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/04 15:06
S12	2	S11 same ((temperature or etch\$3) near resist\$3)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/04 15:05
S13	1918	((silicon near nitride or "Si.sub.3 N. sub.4") same silicon) same ((etch\$3 or temperature) near resist\$3)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/04 15:07

## EAST Search History

S14	49	S13 and (photonic or solar near cell)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/04 15:27
S15	2791	(solar near cell).clm.	USPAT	OR	OFF	2006/11/04 15:28
S16	1676	S15 and silicon	USPAT	OR	OFF	2006/11/04 15:28
S17	10	S16 and ((silicon near nitride) same ((etch\$3 or temperature) near resist\$3))	USPAT	OR	OFF	2006/11/04 15:29